

#3  
Pre Amended A  
3.7.02  
RJV  
Patent

Attorney's Docket No. 030681-332

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
Hae-seok PARK et al. ) Group Art Unit: Unassigned  
Application No.: New Application ) Examiner: Unassigned  
Filed: Herewith )  
For: MICROMIRROR ACTUATOR )

**PRELIMINARY AMENDMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Prior to examination on the merits, kindly amend the above-captioned application as follows:

**IN THE SPECIFICATION:**

Kindly add the following paragraph on page 1, after the title of the invention and before the "Background of the Invention," } Priority is claimed to Patent Application  
number 2000-73483 filed 5 December 2001 in the Republic of Korea, herein incorporated  
by reference.--

Kindly replace the paragraph beginning at page 4, line 20-30 with the following:

A groove 50 is formed to a predetermined depth in the substrate 10, and an inclined  
contact surface 51 which will contact the lower bottom surface of the mirror 30 is formed